



PATENT
Attorney Docket No. 04329.2409-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kei YOSHIKAWA et al.

Application No.: 09/662,219

Filed: September 14, 2000

For: PATTERN CORRECTING METHOD OF
MASK FOR MANUFACTURING A
SEMICONDUCTOR DEVICE AND
RECORDING MEDIUM HAVING
RECORDED ITS PATTERN
CORRECTING METHOD

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) Group Art Unit: 2624
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) Examiner: Samir Anwar AHMED
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) Confirmation No.: 9438
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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed April 6, 2007, the period for response having been extended to September 6, 2007, by a request for extension of two months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Specification are included in this paper.

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.